

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Application of:

SANG-HO CHUN et al.

Serial No.: *to be assigned*

Examiner: *to be assigned*

Filed: 20 February 2002

Unit: *to be assigned*

For: MASK ASSEMBLY FOR CATHODE RAY TUBE

**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner  
for Patents  
Washington, D.C. 20231

Sir:

In accordance with 37 C.F.R. §1.56, and §§1.97 and 1.98 as amended, Applicants cite and provide copies of the following art references:

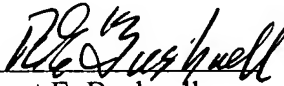
1. U.S. Patent No. 4,926,089 to Moore, entitled *TIED SLIT FOIL SHADOW MASK WITH FALSE TIES*, issued on May 15, 1990;
2. U.S. Patent No. 4,942,332 to Adler *et al.*, entitled *TIED SLIT MASK FOR COLOR CATHODE RAY TUBES*, issued on July 17, 1990; and

3. U.S. Patent No. 3,638,063 to Tachikawa *et al.*, entitled *GRID STRUCTURE FOR COLOR PICTURE TUBES*, issued on January 25, 1972.

The citation of the foregoing references is not intended to constitute an assertion that other or more relevant art does not exist. Accordingly, the Examiner is requested to make a wide-ranging and thorough search of the relevant art.

No fee is incurred by this Statement.

Respectfully submitted,

  
Robert E. Bushnell  
Reg. No.: 27,774

1522 "K" Street, N.W., Suite 300  
Washington, D.C. 20005  
Area Code: 202-408-9040

Folio: P56669  
Date: 20 February 2002  
I.D.: REB/mn

# INFORMATION DISCLOSURE STATEMENT

PTO-1449

SERIAL NUMBER *to be assigned*

DOCKET NO. P56669

APPLICANT SANG-HO CHUN *et al.*

FILING DATE 20 February 2002

GROUP *to be assigned*

JCS78 U.S. PTO  
10/077761  
02/20/02

## U.S. PATENT DOCUMENTS

EXAMINE	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	4,926,089	5/90	Moore			
	4,942,332	7/90	Adler et al.			
	3,638,063	1/72	Tachikawa et al.			

## FOREIGN PATENT DOCUMENTS

TRANSLATION

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)


EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP §609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.